

<b>Notice of References Cited</b>	Application/Control No. 10/081,968	Applicant(s)/Patent Under Reexamination FUJINO ET AL.	
	Examiner Jacob Y. Choi	Art Unit 2875	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,669,356	12-2003	Okuno, Hiroshi	362/311
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

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	N					
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**NON-PATENT DOCUMENTS**

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